



AF / IJG

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/594,635

Group Art Unit: 1793

Filing Date: September 28, 2006

Examiner: Shuangyi Abu Ali

Applicant: Yoshiharu OHTA et al.

Title: SEMICONDUCTOR POLISHING COMPOSITION (As Amended)

Attorney Docket: 2691-000050/US

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314  
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Date: December 29, 2009

**REQUEST FOR RECONSIDERATION**

Sir:

In response to the Office Action mailed August 10, 2009, the shortened statutory period for reply being extended to January 10, 2010 by the attached Extension of Time, the following remarks are respectfully submitted.

**A listing of the Claims** begin on page 2 of this paper.

**Remarks** begin on page 4 of this paper.

	<b>Claims remaining after Amendment</b>		<b>Highest number previously paid for</b>		<b>Present extra</b>
<b>Total</b>	12	-	20	=	0
<b>Independent</b>	1	-	3	=	0